

Self-shadowing and surface diffusion effects in oblique

Thin Solid Films

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Citation Report

#	ARTICLE	IF	CITATIONS
1	Periodic magnetic microstructures by glancing angle deposition. Journal of Vacuum Science and Technology A: Vacuum, Surfaces and Films, 2000, 18, 1838-1844.	0.9	90
2	Origin and evolution of sculptured thin films. Journal of Vacuum Science and Technology A: Vacuum, Surfaces and Films, 2000, 18, 1538-1545.	0.9	221
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